

JEOL JSM-7100FTLV Electron-Beam Lithography



- Accelerating voltage: 0.01 to 30kV
- Beam Current Range: 3pA to 200nA
- Beam Blanker with rise/fall times of $\leq 1\mu\text{sec}$.
- Fine Z stage control to $\sim 1\mu\text{m}$